



Atty. Dkt. No. 039153-0306 (F0793)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Piao et al.

Title: CONFIGURABLE RETICLE FOR  
LITHOGRAPHY AND A METHOD  
OF MAKING INTEGRATED  
CIRCUITS USING SUCH A  
RETICLE

Appl. No.: 09/775,059

Filing Date: 02/01/2001

Examiner: Unknown

Art Unit: 2811

ATTENTION: **DRAWING REVIEW BRANCH**  
U.S. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

<p><b>CERTIFICATE OF MAILING</b></p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below.</p> <p><u>Chris Escavaille</u> (Printed Name)</p> <p><u>Chris Escavaille</u> (Signature)</p> <p><u>March 29, 2002</u> (Date of Deposit)</p>
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APR 22 2002  
TC 1700

**REQUEST TO APPROVE DRAWING CHANGES**

The Applicant hereby proposes to revise the drawings as hand-corrected on the attached drawing sheet (Fig. 2). The Applicant will submit new formal drawings upon allowance of the application. Approval of the proposed drawing changes is hereby respectfully requested.

Respectfully submitted,

Date 3-29-02  
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